## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Fuyutoshi SATO et al.

Application No.: New U.S. Patent Application

Filed: September 23, 2003 Docket No.: 117256

For: LEAD-FREE PIEZOELECTRIC CERAMIC COMPOSITION WHEREIN Cu IS

CONTAINED IN (K<sub>x</sub>A<sub>1-x</sub>)<sub>y</sub>(Nb<sub>1-z</sub>B<sub>z</sub>)O<sub>3</sub> PEROVSKITE COMPOUND, AND PROCESS OF

PREPARING THE SAME

**INFORMATION DISCLOSURE STATEMENT** 

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of the non-English language reference 1 is discussed in the present specification.
- 3. An English-language Abstract of the non-English language reference 1 is attached hereto.
- 4. A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See Reference 1.
- 5. A concise explanation of the relevance of the non-English language reference 2 appears in the Appendix attached hereto.

Respectfully submitted,

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JAO:TJP/smk

Date: September 23, 2003

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry;

Charge any fee due to our Deposit Account No. 15-0461

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Form PTO-1449 US Dept. of Commerce (REV. 8-83) PATENT & TRADEMARK OFFICE				ATTY DOCKET NO. 117256			APPLICATION NO. New U.S. Patent Application		
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(Use several sheets if necessary)				APPLICANTS Fuyutoshi SATO et al.					
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	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)  2 OM. Matubara., W. Sakamoto, T. Yogo and S. Hirano, "Fabriction and characterization of lead-free K <sub>x</sub> Na <sub>i</sub> -Xnb <sub>y</sub> Ta <sub>1-y</sub> O <sub>3</sub> piezoelectric ceramics", March 24, 2002, 2 pgs, Preprints of Annual Meeting of The Ceramic Society of Japan, 2000								
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Date: September 23, 2003